INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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First Named Inventor	Chambless	
Art Unit	2129	
Examiner Name	Lut Wong	

U.S. PATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent applications, provide the application number and the filing date and submit a copy.

Examiner's Initials*	Cite No. (optional)	Number	Date	Name of Applicant or Patentee
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		Dimpsey, et al., "A Measurement-Based Model to Predict the Performance Impact of System Modifications: A Case Study," <i>IEEE Transactions on Parallel and Distributed Systems</i> , Vol. 6, No. 1, 1995, pp. 28-40, 13 pages.					
		Kulonda, Dennis J., "Reengineering Training for Performance Improvement,"					
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EXAMINER	DATE
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